**Reference Numerals**

	11, 22, 59, 81, 108 Piezoelectric thin film
	12, 26a, 26b, 26c, 34, 51, 64, 82, 94, 103 Pressure chamber
	13, 33, 52, 63, 83, 106 Ink channel
5	14, 46, 53, 74, 84a, 84b, 93, 102 Ink outlet
	15, 43, 54, 73 Through-hole
	16, 35, 55, 65, 85, 95, 104 Ink inlet
	17, 31, 56, 61 First silicon substrate
	18, 41, 57, 71 Glass substrate
10	19, 44, 58, 72 Second silicon substrate
	20, 28, 89, 109 Elastic body
	21 Individual electrode
	23 Material for the individual electrode
	23a, 23b, 23c, 90a, 90b Individual electrode
15	24, 60, 110 MgO substrate for the piezoelectric thin film
	25 Resin material
	27, 86, 91, 101 Silicon substrate
	32a, 32b, 32c, 42a, 42b, 45, 67, 92a, 92b Resist
	62 First resist
20	66 Sealing glass substrate
	67 Second resist
	68 First glass through-hole
	69 Second glass through-hole
	87, 105 First glass substrate
25	88, 107 Second glass substrate

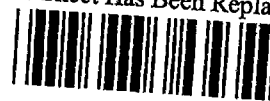
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31

130 Recessed portion

140 Cutting-plane line

This Sheet Has Been Replaced



THIS SHEET HAS BEEN
REPLACED